



<p style="text-align: center;">Form 1449 (Modified)</p> <p style="text-align: center;">Information Disclosure Statement By Applicant</p> <p style="text-align: center;">(Use Several Sheets if Necessary)</p>	<p>Atty Docket No. NOVLP075/NVLS-000820</p> <p>Applicant: Tipton et al.</p> <p>Filing Date September 26, 2003</p>	<p>Application No.: 10/672,311</p> <p>Group 2823</p>
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U.S. Patent Documents

Foreign Patent or Published Foreign Patent Application

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
WC	C1	Cho et al., "Method for Porogen Removal and Mechanical Strength Enhancement of Low-K Carbon Doped Silicon Oxide Using Low Thermal Budget Microwave Curing", U.S. Application No. 11/280,113, filed November 15, 2005 (Atty Dkt: NOVLP145/NVLS-3106)

Examiner: Initial citation considered. Draw line through citation if not in conformance and not
allowable. Include in Stat. Search if citation is relied upon. A line through a citation does not preclude
the examiner from relying on the citation if the citation is otherwise allowable.



Form 1449 (Modified)

**Information Disclosure
Statement By Applicant**

(Use Several Sheets if Necessary)

Atty Docket No. NOVLP075/NVLS-000820 Application No.: 10/672,311

Applicant:

Tipton et al.

Filing Date

September 26, 2003

Group
2823

U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
WC	A1	5,849,640	12.1998	Hsia et al.			
WC	A2	6,797,643 B2	09.2004	Rocha-Alvarez et al.			
WC	A3	6,815,373 B2	11.2004	Singh et al.			
WC	A4	6,914,014 B2	07.2005	Li et al.			
WC	A5	2004/0101633 A1	05.2004	Zheng et al.			
WC	A6	6,258,735 B1	07.2001	Xia et al.			
WC	A7	6,610,362 B1	08.2003	Towle, Steven N.			
WC	A8	6,632,478 B2	10.2003	Gaillard et al.			
WC	A9	2004/0096593 A1	05.2004	Lukas et al.			
WC	A10	2004/0161532 A1	08.2004	Kloster et al.			
WC	A11	2004/0170760 A1	09.2004	Meagley et al.			
WC	A12	2005/0064698 A1	03.2005	Chang et al.			
WC	A13	6,715,498 B1	04.2004	Humayun et al.			

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation
							Yes

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
WC	C1	U.S. Office Action mailed December 20, 2005, from U.S Application No. 10/849,568 [Atty Dkt No. NOVLP083/NVLS-2867].
WC	C2	U.S. Office Action mailed January 9, 2006, from U.S Application No. 10/785,235 [Atty Dkt No. NOVLP085/NVLS-2875].
WC	C3	U.S. Office Action mailed December 27, 2005, from U.S Application No. 10/789,103 [Atty Dkt No. NOVLP094/NVLS-002919].
WC	C4	U.S. Office Action mailed December 23, 2005, from U.S Application No. 10/800,409 [Atty Dkt No. NOVLP098/NVLS-002907].
WC	C5	U.S. Office Action mailed February 7, 2006, from U.S Application No. 10/672,305 [Atty Dkt No. NOVLP069/NVLS-000821].
WC	C6	Subramonium et al., "Pulsed PECVD Method for Modulating Hydrogen Content in Hard Mask", U.S. Application No. 11/318,269, filed December 23, 2005 (Atty Dkt: NOVLP144/NVLS-3102)

Examiner *[Signature]* Date Considered 05/11/2006

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Date: 2006-05-11 12:45:24 -04'00'

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



Form 1440 (2000) (Modified)	Atty Docket No. NOVLP075/NVLS-000820	Application No.: 10/672,311
Information Disclosure Statement By Applicant	Applicant: Tipton et al.	
(Use Several Sheets if Necessary)	Filing Date September 26, 2003	Group 2823

U.S. Patent Documents

Foreign Patent or Published Foreign Patent Application

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
WC	C1	U.S. Office Action mailed February 28, 2006, from U.S Application No. 10/404,693 [Atty Dkt No. NOVLP064/NVLS-794].
WC	C2	U.S. Office Action mailed March 29, 2006, from U.S Application No. 10/800,377 [Atty Dkt No. NOVLP089/NVLS-002886].
Examiner	Digitally signed by W. David Coleman DN: cn=W. David Coleman, c=US, o=USPTO, ou=2023, email=W.D.Coleman@uspto.gov Reason: I have reviewed this document Date: 2006.05.11 10:47:59 -04'00	
	Date Considered	05/11/2006

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